Cee® CoPro™

HYBRID WORKSTATION



The **Freedom** of R&D | The **Power** of Automation

Cee
Cost Effective Equipment

COSTEFFECTIVEEQUIPMENT.COM +1.573.466.4300 SERVING THE SEMICONDUCTOR INDUSTRY SINCE 1987

Cost Effective Equipment

CoPro™ Hybrid Workstation

Key Features

Customizable configuration
Accomodates up to four 200 mm process modules

Integrated collaborative robot (cobot)
Automated precision wafer handling between processes

Dual-cassettes
Maximize batch flexibility

Choice of ducted exhaust enclosure or fan filter unit
Laminar downflow option

Wafer Flexibility
2" to 200 mm round

Exhausted sub-cabinet
Secondary containment with leak sensors for chemicals

Sash
Clean environment, fume containment, and operator safety

NRTL Certified
Evaluated and certified by a Nationally Recognized Testing Laboratory to applicable U.L. safety standards.

UTILITIES	
Voltage	208-230 VAC, 50/60 Hz 1 phase
Full Load Current	26.2 A (max)
Nitrogen (N2)	1/4" PTC, 70 psi (482 kPa)
Vacuum	< 20" HG (33 kPa) 1/4" PTC or 1/4" FNPT
Hood Exhaust* **	8" OD, 0.4" H_2O 540 cfm (100 Pa @ 917 CMH)
Cabinet Exhaust	4" OD, 0.4" H2O 20 cfm (100 Pa @ 34 CMH)

***If equipped with Ducted Exhaust Hood

Individual modules may require additional exhaust & drain requirements

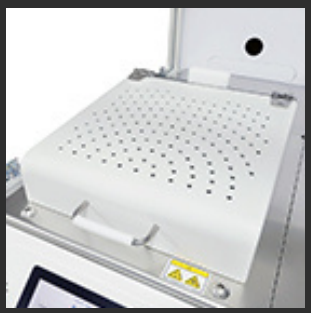
DIMENSIONS	
Width	85" (216 cm)
Depth	44" (112 cm)
Height	82" (208 cm)
Machine Weight*	1300 lb (590 kg)
Shipping Weight*	1500 lb (680 kg)

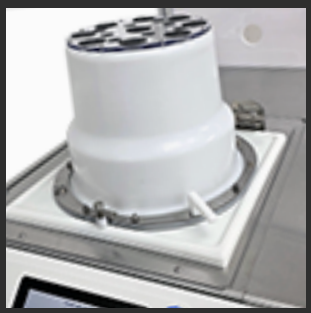
**Weight varies depending on process modules*

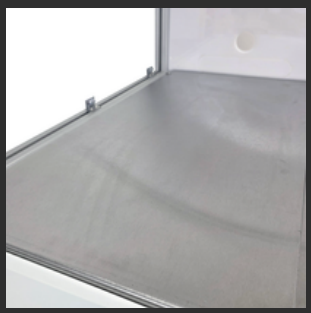
Available Process Modules

BUILD YOUR PROCESS YOUR WAY


Apogee® Spin Coater


Apogee® Bake Plate


Apogee® Spin Developer


Working Surface


DI Sink